



Atty. Dkt. No.	M#	Client Ref.
	305541	P-0352.010-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: BAKKER et al.	
Appln. No.: 10/644,954	
Filing Date: August 21, 2003	
Examiner:	Group Art Unit: 2881

Date: February 11, 2004

Page 1 of 1

U.S. PATENT DOCUMENTS

Examiner's Initials	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
JP	AR 6,594,334 B1	07/2003	OTA			
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		Abstract		Readily Available	
							Enclosed	No	Enclose	No
	LR									
	MR									
	NR									
	OR									
	PR									
	QR									
	RR									
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OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	TR						
	UR						
	VR						
	WR						
	XR						
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	ZR						
	AAR						
	BBR						
	CCR						

Examiner: [Signature] Date Considered: 08/27/04

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office

Atty.
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Client Ref.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: BAKKER et al.

Appln. No.: TO BE ASSIGNED

Filing Date: August 21, 2003

Date: August 21, 2003

Page

1

of

1

Examiner:

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	4,408,338	10/1983	GROBMAN			
	BR	6,262,796	07/2001	LOOPSTRA et al.			
	CR	6,359,969	03/2002	SHMAENOK			
	DR	2002/0084428	07/2002	VISSER et al.			
	ER	2002/0090054	07/2002	SOGARD			
	FR	2002/0154279	10/2002	KOSTER et al.			
	GR	2003/0020890	01/2003	MIYAKE et al.			
	HR	2003/0095623	05/2003	SINGER et al.			
	IR						
	JR						
	KR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
							Enclosed	No	Enclose	No
	LR	2000-349009	12/2000	JAPAN	OTA		X			
	MR									
	NR									
	OR									
	PR									
	QR									
	RR									
	SR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	TR	Partlo et al., "Development of an EUV (13.5nm) Light Source Employing a Dense Plasma Focus in Lithium Vapor," <i>Proc. of SPIE</i> Vol. 3997:136-156, Emerging Lithographic Technologies IV, ed. E. Dobisz (March 2000)			
	UR	McGeoch, "Power Scaling of a Z-Pinch Extreme Ultraviolet Source," <i>Proc. of SPIE</i> Vol. 3997:861-866, Emerging Lithographic Technologies IV, ed. E. Dobisz (March 2000)			
	VR				
	WR				
	XR				
	YR				
	ZR				

Examiner

Date Considered:

08/27/04

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